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AF/2876  
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RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2876

00862.022319

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Ken MATSUMOTO ) : Examiner: L. M. Caputo  
Application No.: 09/920,752 ) : Group Art Unit: 2876  
Filed: August 3, 2001 ) : Confirmation No.: 5950  
For: SUBSTRATE TRANSFER APPARATUS, ) :  
SEMICONDUCTOR MANUFACTURING ) :  
APPARATUS, AND SEMICONDUCTOR ) June 28, 2004  
DEVICE MANUFACTURING METHOD : (Monday)

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated April 26, 2004, the time for response being extended from Saturday, June 26, 2004 to Monday, June 28, 2004, please amend the above-identified application as follows, pursuant to 37 C.F.R. § 1.116:

Do not enter me 7/8/04